

Form PTO 1449
(Modified)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY DOCKET NO.
247051US2XRDSERIAL NO. *14/743,087*
New Application

LIST OF REFERENCES CITED BY APPLICANT

APPLICANT
*Hideto FURUYAMA*FILING DATE
*Herewith*GROUP
1402

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
					YES	NO
<i>F.H.</i>	AO	11-307878	11/05/99	Japan (with English Abstract)		
	AP					
	AQ					
	AR					
	AS					
	AT					
	AU					
	AV					

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)

<i>F.H.</i>	AW	Eli Yablonovitch, et al., "Extreme selectivity in the lift-off of epitaxial GaAs films", APPLIED PHYSICS LETTERS, Vol. 51, No. 26, December 28, 1987, Pages 2222-2224				
<i>F.H.</i>	AX	Nan M. Jokerst, et al., "Microsystem Optoelectronic Integration for Mixed Multisignal Systems", IEEE JOURNAL ON SELECTED TOPICS IN QUANTUM ELECTRONICS, Vol. 6, No. 6, November/December 2000, Pages 1231-1239				
	AY					
	AZ					

☐ Additional References sheet(s) attached

Examiner

Date Considered *3/22/06*

*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.